

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :

Sang Hun OH : GROUP ART UNIT: 1756

APPLICATION NO: 10/764,905 :

FILED: JANUARY 26, 2004 : EXAMINER: SULLIVAN, Caeleen O.

FOR: METHODS FOR FORMING AN AIR  
GAP IN A SEMICONDUCTOR  
METAL LINE MANUFACTURING  
PROCESS

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 27, 2007.

By: /Andrew D. Fortney/  
Andrew D. Fortney

AMENDMENT AND REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132  
AND 37 C.F.R. 1.111(a)(2)

Mail Stop AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

Supplemental to the Request for Continued Examination filed October 15, 2007, Applicant respectfully requests reconsideration of the above-identified application in view of the following amendments and remarks.